



Attorney Docket No. 0756-7293

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA et al.

Serial No. 10/827,449

Filed: April 20, 2004

For: BEAM HOMOGENIZER, LASER
IRRADIATION APPRATUS, AND
METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 2874

) Examiner: Michael J. Stahl

) CERTIFICATE OF MAILING

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) 2006.

) Adrian M. Stamps

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated August 11, 2006, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 13 of this paper.